



PATENT

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October 6, 2003  
Date

Tamra Miller  
Tamra Miller

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No. :	09/970,100	Confirmation No. :	2699
Applicants :	Vishnu K. Agarwal and Scott G. Meikle	Attorney Docket No.:	500453.04 (29113/US/3)
Filed :	October 2, 2001	Customer No. :	27,076
Art Unit :	1762		
Examiner :	William P. Fletcher III		
Title :	POLISHING PADS AND PLANARIZING MACHINES FOR MECHANICAL OR CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE SUBSTRATE ASSEMBLIES, AND METHODS FOR MAKING AND USING SUCH PADS AND MACHINES		

**AMENDMENT UNDER 37 C.F.R. §1.114**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.